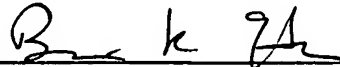


The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449.

If the sum of \$180.00 is due under 37 CFR § 1.17(p) pursuant to § 1.97, the Commissioner is hereby authorized to charge this fee, and any other fee necessary to make this submission timely, to the Deposit Account No.20-0782/AMAT/8390/BKH.

Respectfully submitted,



Brian K. Hrna
Registration No. 41,852
MOSER, PATTERSON & SHERIDAN, L.L.P.
3040 Post Oak Blvd. Suite 1500
Houston, TX 77056
Telephone: (713) 623-4844
Facsimile: (713) 623-4846
Attorney for Applicant(s)



Please type a plus sign (+) inside this box → ☐

PTO/SB/08a (08-03)

Approved for use through 07/31/2006. OMB 0651-0031
U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number.

Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet 1

of 6

Application Number	10/799,147
Filing Date	MARCH 12, 2004
First Named Inventor	LAURENT VANDROUX, ET AL.
Group Art Unit	UNKNOWN
Examiner Name	UNKNOWN
Attorney Docket Number	AMAT/8390/DSM/BCVD/JW
Submission Date	_____, 2004

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
	A1	US-6,635,583 B2	10/21/2003	Bencher, et al.	
	A2	US-6,624,064 B1	09/23/2003	Sahin, et al.	
	A3	US-6,573,030	06/03/2003	Fairbairn, et al.	
	A4	US-6,541,397 B1	04/01/2003	Bencher	
	A5	US-6,458,516 B1	10/01/2002	Ye, et al.	
	A6	US-6,423,384 B1	07/23/2002	Khazeni, et al.	
	A7	US-6,413,852	07/02/2002	Grill, et al.	
	A8	US-6,386,947	05/14/2002	Donahue	
	A9	US-6,380,106	04/30/2002	Lim, et al.	
	A10	US-6,358,573 B1	03/19/2002	Raoux, et al.	
	A11	US-6,333,255	12/25/2001	Sekiguchi	
	A12	US-6,331,380 B1	12/18/2001	Ye, et al.	
	A13	US-6,323,119 B1	11/27/2001	Xi, et al.	
	A14	US-6,316,347	11/13/2001	Chang, et al.	
	A15	US-6,291,334 B1	09/18/2001	Somekh	
	A16	US-6,235,629	05/22/2001	Takenaka	
	A17	US-6,214,730	04/10/2001	Cooney, III, et al.	
	A18	US-6,211,065 B1	04/03/2001	Xi, et al.	

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				
	B1	EP 0 575 157 A1	12/22/1993			
	B2	EP 0 803 589 A1	10/26/1997			
	B3	EP 1 014 121 A2	06/28/2000			
	B4	DE 197 23 284 A1	10/12/1998			
	B5	JP 06-263452	09/06/1994			
	B6	JP 11-052159	02/11/1999			

Examiner

Date Considered

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450. If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number.

Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>				Application Number	10/799,147
				Filing Date	MARCH 12, 2004
				First Named Inventor	LAURENT VANDROUX, ET AL.
				Group Art Unit	UNKNOWN
				Examiner Name	UNKNOWN
				Attorney Docket Number	AMAT/8390/DSM/BCVD/JW
Sheet 2		of 6		Submission Date	_____, 2004

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
	A19	US-6,165,890	12/26/2000	Kohl, et al.	
	A20	US-6,153,935	11/28/2000	Edelstein, et al.	
	A21	US-6,151,430	11/21/2000	Traver, Jr, et al.	
	A22	US-6,143,476	11/07/2000	Ye, et al.	
	A23	US-6,140,226	10/31/2000	Grill, et al.	
	A24	US-6,140,224	10/31/2000	Lin	
	A25	US-6,098,568	08/08/2000	Raoux, et al.	
	A26	US-6,097,870	08/01/2000	Ranka, et al.	
	A27	US-6,080,529	06/27/2000	Ye, et al.	
	A28	US-6,066,577	05/23/2000	Cooney, III, et al.	
	A29	US-6,064,118	05/16/2000	Sasaki	
	A30	US-6,057,226	05/02/2000	Wong	
	A31	US-6,035,803	03/14/2000	Robles, et al.	
	A32	US-6,030,901	02/29/2000	Hopper, et al.	
	A33	US-6,024,044	02/15/2000	Law, et al.	
	A34	US-6,008,140	12/28/1999	Ye, et al.	
	A35	US-5,999,293	12/07/1999	Manning	
	A36	US-5,961,924	10/05/1999	Reichert, et al.	
	A37	US-5,986,344	11/16/1999	Subramanion, et al.	
	A38	US-5,949,934	09/17/1999	Shima, et al.	
	A39	US-5,930,439	07/27/1999	Ojha, et al.	
	A40	US-5,904,491	05/18/1999	Ojha, et al.	
	A41	US-5,900,288	05/04/1999	Kuhman, et al.	
	A42	US-5,881,199	03/09/1999	Li	
	A43	US-5,866,920	02/02/1999	Matsumoto, et al.	
	A44	US-5,858,051	01/12/1999	Komiyama, et al.	
	A45	US-5,789,320	08/04/1998	Andricacos, et al.	
	A46	US-5,770,465	06/23/1998	MacDonald, et al.	

Examiner	Date Considered
----------	-----------------

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450. If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2.

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number.

Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>				Application Number	10/799,147
				Filing Date	MARCH 12, 2004
				First Named Inventor	LAURENT VANDROUX, ET AL.
				Group Art Unit	UNKNOWN
				Examiner Name	UNKNOWN
				Attorney Docket Number	AMAT/8390/DSM/BCVD/JW
Sheet 3	of 6	Submission Date		_____, 2004	

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
	A47	US-5,759,913	06/02/1998	Fulford, Jr., et al.	
	A48	US-5,689,614	11/18/1997	Gronet, et al.	
	A49	US-5,567,476	10/22/1996	Law, et al.	
	A50	US-5,465,860	11/14/1995	Fujimoto, et al.	
	A51	US-5,461,003	10/24/1995	Havemann, et al.	
	A52	US-5,378,256	01/03/1995	Green, et al.	
	A53	US-5,366,530	11/22/1994	Weber	
	A54	US-5,333,229	07/26/1994	Sayegh	
	A55	US-5,263,111	11/16/1993	Nurse, et al.	
	A56	US-5,253,319	10/12/1993	Bhagavatula	
	A57	US-5,165,004	11/17/2002	Okamoto, et al.	
	A58	US-5,125,946	06/30/1992	Bhagavatula	
	A59	US-4,972,799	11/27/1990	Misumi, et al.	
	A60	US-4,904,052	02/27/1990	Rand, et al.	
	A61	US-4,896,930	01/30/1990	Tsuchitani, et al.	
	A62	US-4,856,859	08/15/1989	Imoto	
	A63	US-4,709,986	12/01/1987	Hicks, Jr.	
	A64	US-4,619,680	10/28/1986	Nourshargh, et al.	
	A65	US-4,578,691	03/25/1986	Murakami, et al.	
	A66	US-4,578,097	03/25/1986	Berkey	
	A67	US-4,426,129	01/17/1984	Matsumura, et al.	
	A68	US-4,425,146	01/10/1984	Izawa, et al.	
	A69	US-2003/0091938 A1	05/15/2003	Fairbairn, et al.	
	A70	US-2002/0090794 A1	07/11/2002	Chang, et al.	
	A71	US-2002/0086547 A1	07/04/2002	Mui, et al.	
	A72	US-2002/0001778 A1	01/03/2002	Latchford, et al.	
	A73	US-2001/0007788 A1	07/12/2001	Chang, et al.	
	A74				

Examiner

Date Considered

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450. If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2



Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number.

Substitute for form 1449B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>				Application Number	10/799,147
				Filing Date	MARCH 12, 2004
				First Named Inventor	LAURENT VANDROUX, ET AL.
				Group Art Unit	UNKNOWN
				Examiner Name	UNKNOWN
				Attorney Docket Number	AMAT/8390/DSM/BCVD/JW
Sheet 4	of 6	Submission Date	_____, 2004		

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²
	C1	U.S. Patent Application 10/768,724, filed on January 30, 2004. (AMAT/8736)	
	C2	U.S. Patent Application 10/799,146, filed on March 12, 2004 (AMAT/8244)	
	C3	U.S. Patent Application 10/800,112, filed on March 12, 2004 (AMAT/8245)	
	C4	U.S. Patent Application 10/383,839, filed on March 7, 2003 (AMAT/6328.C1)	
	C5	PCT International Search Report for PCT/US 01/47493, dated December 10, 2002 (AMAT/5621.PC)	
	C6	PCT Written Opinion for PCT/US 01/47493, dated March 12, 2004 (AMAT/5621.PC)	
	C7	A. KILIAN, ET AL. "Birefringence Free Planar Optical Waveguide Made by Flame Hydrolysis Deposition (FHD) Through Tailoring of the Overcladding", <i>J. Lightwave Tech.</i> Vol. 18. No. 2 (Feb. 2000)	
	C8	KASHIMURA, ET AL., "Loss Reduction of GeO ₂ -Doped Silica Waveguide with High Refractive Index Difference By High-Temperature Annealing", 39 <i>Jpn. J. Appl. Phys.</i> Vol. 39 No.6A, Pt. 2 (April 2000)	
	C9	TAN, ET AL., "Fabrication of Gratings and Design of Diffractive Optical Elements Embossed on Sol-Gel Films" <i>SPIE Conf. on Design, Fabrication & Characterization of Photonic Devices</i> (November 1999)	
	C10	SUN, ET AL., "Building Passive Components with Silica Waveguides", <i>SPIE Conf. on Terahertz & Gigahertz Photonics</i> , pp. 313 – 319 (July 1999)	
	C11	JUNG, ET AL., "Inductively Coupled Plasma Etching of Ge-Doped Boron-Phosphosilicate Glass for Planar Lightwave Circuit Devices", <i>J. Non-Crystalline Solids</i> , Vol 259, pp. 191 – 197 (1999)	

Examiner

Date Considered

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450. If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2



Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number.

Substitute for form 1449B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>				Application Number	10/799,147
				Filing Date	MARCH 12, 2004
				First Named Inventor	LAURENT VANDROUX, ET AL.
				Group Art Unit	UNKNOWN
				Examiner Name	UNKNOWN
				Attorney Docket Number	AMAT/8390/DSM/BCVD/JW
Sheet	5	of	6	Submission Date	_____, 2004

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²
	C12	RUANO, ET AL. "Fabrication of Integrated Microanalytical Chambers and Channels for Biological Assays Using Flame Hydrolysis Deposition Glass", <i>Microelectronic Eng.</i> , Vol. 46 (1999), pp. 419 - 422	
	C13	RUANO, ET AL., "Lab-on-a-Chip Devices Fabricated Using Flame Hydrolysis Deposited Glass", <i>Inst. Of Elec. Eng.</i> (1999), pp. 12/1 - 12/6	
	C14	ANDREWS. M., "An Overview of Sol Gel Guest-Host Materials Chemistry for Optical Devices", 2997 SPIE (1997), pp. 48-59	
	C15	KOBAYASHI, S., "Recent Development on Silica Waveguide Technology for Integrated Optics, 2997 SPIE (1997), pp. 264 - 270	
	C16	DING, ET AL., "Wavelet Structural Analysis of Silica Glasses Manufactured by Different Methods", <i>J. Non-Crystalline Sol.</i> , Vol. 222 (1997), pp. 50-58	
	C17	BEGUIN, ET AL., "Planar Optical Devices for Use in Multi-Wavelength Systems", IEEE (1997), pp. 504-505	
	C18	OJHA, "Fabrication Technologies for Planar Waveguide WDM Components", 3211 SPIE (December 1996), pp.612 - 621	
	C19	CHUN, ET AL. "Birefringence Reduction in a High Boron-Doped Silica-on-Silicon Planar Optical Waveguide", <i>J. Korean Phys. Soc.</i> , Vol. 29, No. 1 (Feb. 1996), pp. 140-142	
	C20	LI, ET AL. "Silica-Based Optical Integrated Circuits", <i>IEE Proc. Optoelectron</i> , Vol. 143, No. 5 (October 1996), pp. 263 - 280	
	C21	WU, ET AL., "Fabrication of High Concentration Rare-Earth-Doped Silica-Based Waveguide by MCVF Method", <i>IEEE Photonics Tech. Letters</i> , Vol. 7, No. 6 (June 1995), pp. 655 - 657	
	C22	SUN, ET AL., "Light Coupling from Diode Lasers to Microlensed Silica Waveguides", <i>Conference on Optical Fiber Communication</i> , Vol. 8 (1995), pp. 228-229	
	C23	SUN, ET AL. "Silica Waveguide Circuits with Low Polarisation Dependence Fabricated on Silica Substrates", <i>Electronics Letters</i> , Vol. 30 (11/24/94), pp. 2032 - 2034	

Examiner

Date Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. 1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450. If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2



Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number.

Substitute for form 1449B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>				Application Number	10/799,147
				Filing Date	MARCH 12, 2004
				First Named Inventor	LAURENT VANDROUX, ET AL.
				Group Art Unit	UNKNOWN
				Examiner Name	UNKNOWN
				Attorney Docket Number	AMAT/8390/DSM/BCVD/JW
Sheet 6		of 6		Submission Date	_____, 2004

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²
	C24	TSUKAHARA, ET AL., "Evaluation of Layered Structures for Micromachines by Means of Ultrasonic Micro-Spectroscopy", 1994 <i>Ultrasonics Symposium</i> (1994), pp. 1429 - 1432	
	C25	SUN, ET AL., "High Silica Waveguides on Alumina Substrates for Hybrid Optoelectronic Integration", <i>IEEE Photonics Tech. Letters</i> , Vol. 4, No. 6 (June 1992), pp. 630-632	
	C26	SUN, ET AL., "Silica-Based Circular Cross-Sectioned Channel Waveguides", <i>IEEE Photonics Tech. Letters</i> , Vol. 3, No. 3 (March 1991), pp. 238-240	
	C27	IKUNISHI, ET AL., "A Study of Fabricating Silica Glass Waveguide by LP-CVD", (1987) pp. 66-69	
	C28	SUN, ET AL., "1xN Splitters on Silica Substrates with Low Polarization Dependent Loss", pp. 243-244	
	C29		
	C30		
	C31		
	C32		
	C33		
	C34		
	C35		

Examiner	Date Considered
----------	-----------------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. 1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450. If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2